

NED is a MEMS transducer principle. A beam-shaped actuator consists of at least two electrodes, which are electrically separated from each other by gaps of 2.5  $\mu$ m down to a few 10 nm. By applying a control voltage, an electrostatic field is generated between these electrodes, resulting in large attractive forces between the electrodes. Suitable geometries of the electrodes in turn transform these forces into lateral forces thus bending the actuators.

The benefits of the NED actuators comprise: #1 Low power consumption ⇒ low capacitance, smallreactive currents and low control voltages enable the use of energy-efficient driver circuits and thus result in low power consumption of the overall system. #2 CMOS compatibility ⇒ integration of actuators with CMOS circuits, RoHS compatibility. #3 High number of degrees of freedom ⇒ beam shape or plate, either deflection direction or combination, translation or tilting movement, cascading serially and/or parallel to increase deflection and/or forces or both.

ducer (NEDMUT) glued on printed circuit board with wirebonds & bondlands

### **Contact**

Dr. Bert Kaiser +49 351 8823-150 bert.kaiser@ipms.fraunhofer.de

Fraunhofer Institute for Photonic Microsystems IPMS Maria-Reiche-Str. 2 01109 Dresden, Germany

www.ipms.fraunhofer.de

# **Bending actuators configurations**

Single entity examples

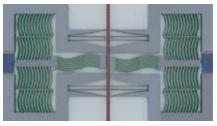
Direction/type	Unit	Out-of-plane (vertical)	In-plane (lateral)
Travel	μm	1	100
Dimension	μm	60 x 4000 x 30	6 x 2000 x 10
Force	μN	1.6	1.6
Voltage	V	90	60

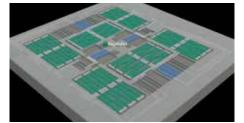
**Electrostatic Drive** 

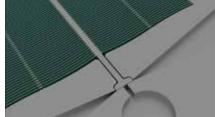
System examples

Direction/type	Unit	Out-of-plane (vertical)	In-plane (lateral)
Travel	μm	> 200	> 500
Dimension	μm	7023 x 3605 x 25	2500 x 1600
Force	μN	> 100	> 3500
Voltage	V	1 250	2.5300

# **Applications**







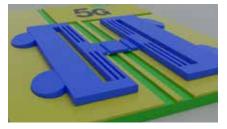
**NED** based Step Drive

NED 2D micromotors

NED microfluidic valves





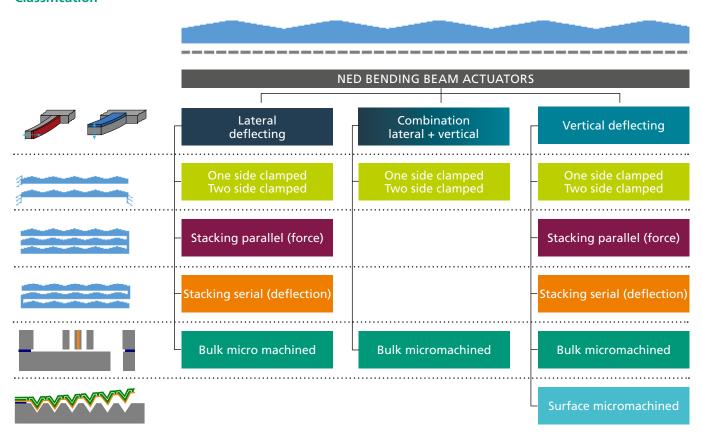


**NEDMUT Ultrasonic Transducer** 

**NED** speaker

**NED RF MEMS Varactor** 

### Classification



# Versatility

Specific adaption for various applications possible. Limited examples available from premanufacturing. User specific fabrication upon request.